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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Ryoichi Matsumoto

Group Art Unit: 2876

Serial No.: 09/864,189

Examiner: T. Le

Filed: May 25, 2001

Conf. No.: 2192

FOR: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

**LETTER SUPPLEMENTAL TO EARLIER FILED INFORMATION DISCLOSURE
STATEMENT**

U.S. Patent and Trademark Office
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Date: January 24, 2006

Sir:

Supplemental to the Information Disclosure Statement filed along with the Amendment on December 21, 2005, enclosed please find an English language abstract of Japanese Patent Publication No. 52-127157.

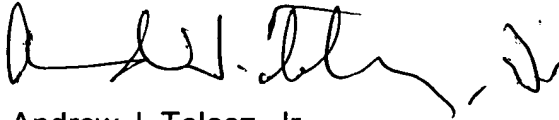
In the event that there are any outstanding matters remaining in the present application, please contact Andrew J. Telesz, Jr. (Reg. No. 33,581) at (571) 283-0720 in the Washington, D.C. area, to discuss these matters.

Serial No.: 09/864,189

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment for any additional fees that may be required, or credit any overpayment, to Deposit Account No. 50-0238.

Respectfully submitted,

VOLENTINE FRANCOS & WHITT, P.L.L.C.

A handwritten signature in black ink, appearing to read "A. J. Telesz, Jr.", with a stylized flourish at the end.

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Enclosures: English abstract of Japanese Patent Publication No. 52-127157